



# We redefine Semiconductor Chip Failure Analysis & Production Metrology with Quantum Sensing

- DIASENSE Quantum Diamond Magnetic Microscope:
- The go-to tool for chip failure analysis
  - The essential tool for in-line semiconductor testing



# The DIASENSE Team

## Operational founders



**Christian D. Nielsen**  
Founder and CEO

Business Development  
Chip designer by trade



**Marvin Holten**  
Founder and CTO

Quantum Physicist

## Advisory founders



**Alex Huck**  
Founder and CSO  
Ass. Prof. at QPIT, DTU



**Ulrik L. Andersen**  
Founder and Sci. Advisor  
Prof. at QPIT, DTU

Founded in Q1'24  
DTU Physics spinout

Located at DTU Physics  
- Quantum Denmark in Q1'26

BioInnovation DTL-Q alumni

## Advisors

**Laura Smolier**  
CEO, Quantum Denmark

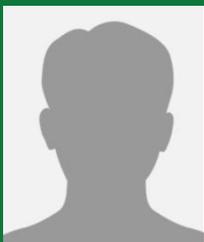
**Tina Moe**  
CEO, Leadership of the Future

**Jakob Svagin**  
Director, BioInnovation Institute

## Team leads



**Samuel Möller**  
Quantum Lead



**Instrument Lead**



**AI-driven  
Imaging Lead**



**Business Lead  
CBO**



**Electrical / DSP  
Engineering**



**Mechanical  
Engineering**

...

## Team members (full-time)

## Part time

**Bjarne Schümann**  
Quantum Information Science

**Marcus Boye Jensen**  
Quantum Optics (October 1<sup>st</sup>)

**Axel Bregnsbo**  
Electrical Engineering

**Per Giese**  
CFO



# Semiconductor Test Tools are Falling Behind

## The chip industry

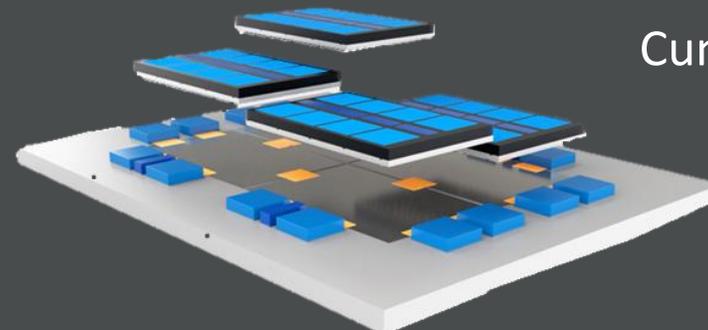
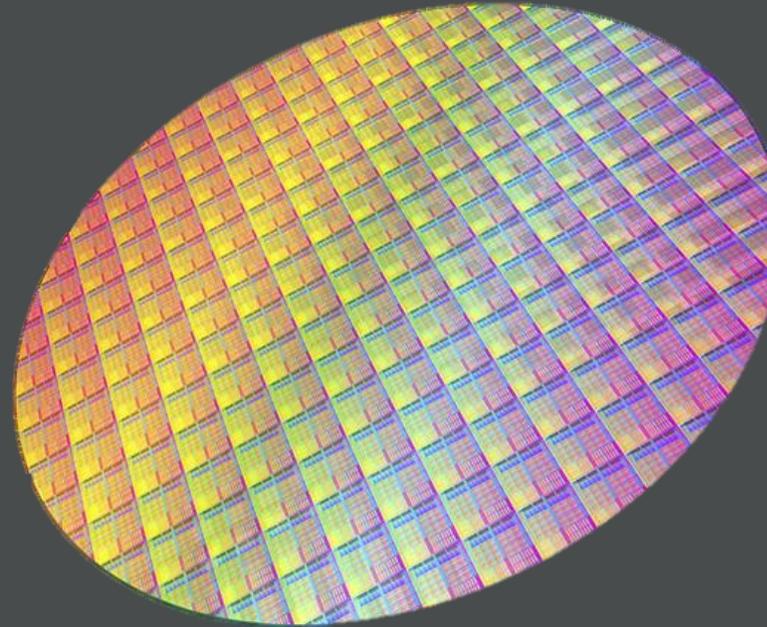


Complexity:

x1000 in 20 years

from 2D to 3D

chiplets and memory stacks



## Chip failure analysis & production metrology - Challenges

Subtle buried faults

Analyzing 3D Stacks – TSVs / RDLs  
- reduced yield and reliability

Cumbersome and limited tools

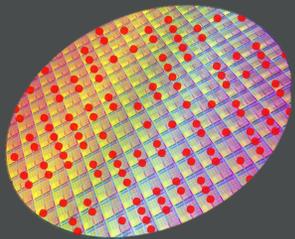


# Semiconductor Test Tools are Falling Behind

Modern semiconductor systems have outgrown existing test and analysis tools



**Time-to-Market:**  
FA takes **weeks – months**



**Yield:**  
**+1% yield = millions of dollars/week**  
for high-volume devices



**Reliability:**  
100s DPPM escapes  
10–100× cost



**Scrap/Waste:**  
~10% of chips scrapped  
in advanced packaging



Test and analysis — not fabs — increasingly limit semiconductor production throughput.



# DIASENSE Quantum Diamond Magnetic Microscope

DIASENSE restores visibility where test and analysis come short

## Value Propositions

### Failure Analysis

High throughput diagnostics

- live navigation and smart analysis tools

High sensitivity: Uncover subtle defects

- detect  $\mu\text{A}$  currents in depth

Non-invasive

- works on bare dies, packaged devices, wafers, and packaging

The go-to tool for chip failure analysis



### Production Test & Metrology

Contactless testing

- leaves wafers, dies, and stacks unharmed

Inspect buried structures non-destructively

- monitor TSVs, RDLs, and 3D interconnects

Fast fingerprinting: detect process variations early

- identify non-uniformities across wafers and stacks

The essential tool for in-line semiconductor testing

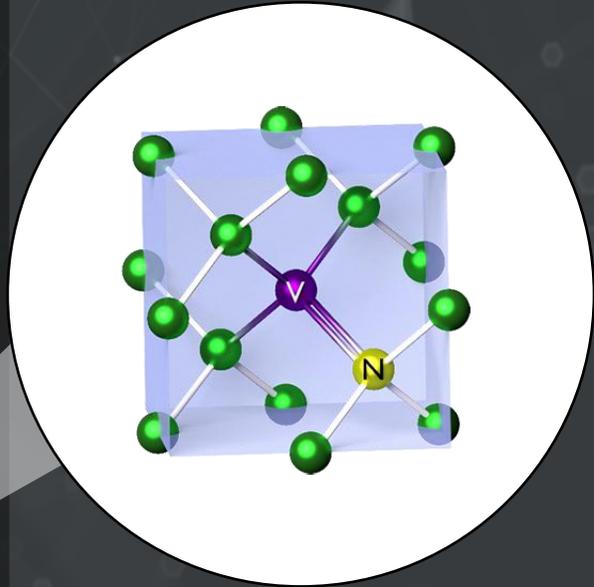
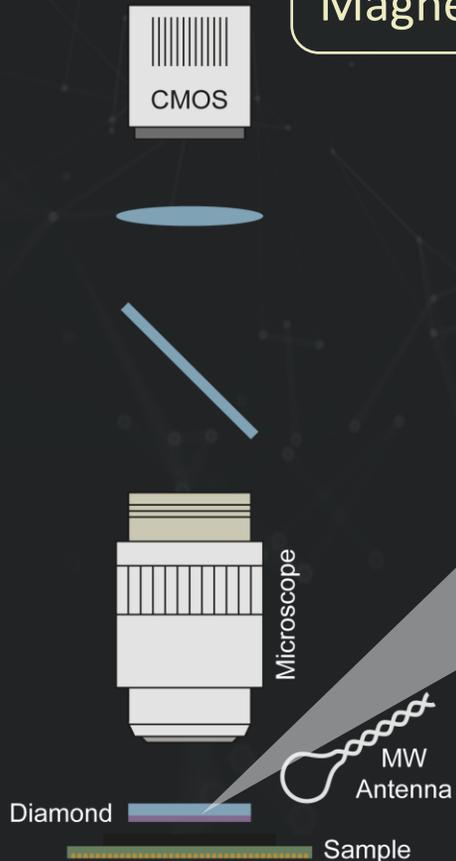




# Quantum Sensing Leveraged!

Our technical foundation – the basics

## The Quantum Diamond Magnetic Microscope (QDMM)



### Quantum Diamonds:

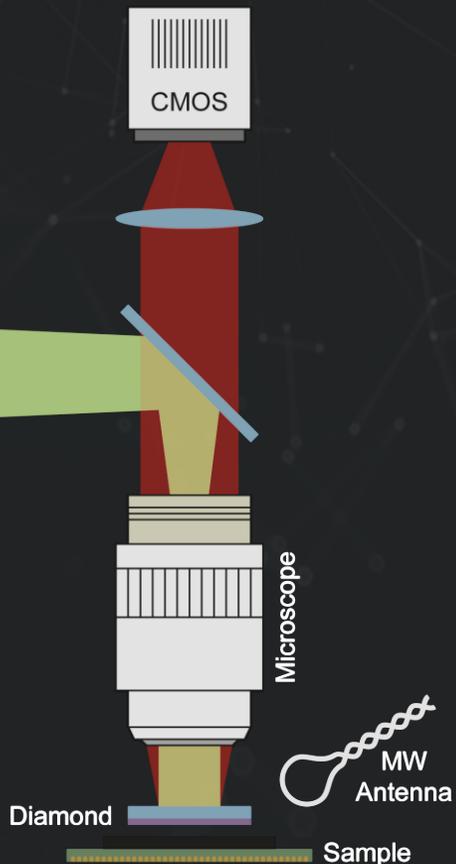
- High density ( $> 100'000 / \mu m^3$ )
- Very high coherence times at RT ( $T_2^* > 1 \mu s$ )
- Direct quantum state readout & manipulation:
  - Laser at  $532 \text{ nm}$
  - Microwaves at  $2 - 3 \text{ GHz}$

*Our QDMMs detects magnetic fields 10 million times weaker than a fridge magnet, from a sensing volume a billion times smaller.*



# Pushing NV sensing beyond CMOS readout

DIASENSE's QDMM will be 100–1000x more sensitive than competing tools based on CMOS camera readout



## CMOS-QDMM:

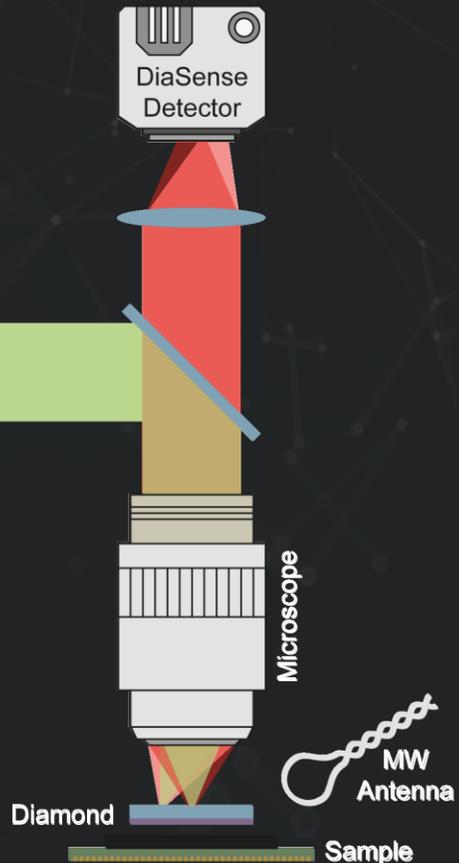
- Spatial resolution:  $< 500nm$
- Measurement Bandwidth:  $< 1 kHz$
- Magnetic Sensitivity:  $10 \mu T / \sqrt{Hz}$

*3 patents applications on detector and drive scheme are filed.  
We have 5+ more in line that will be filed during 2026.*



# Pushing NV sensing beyond CMOS readout

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## CMOS-QDMM:

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## DiaSense next-gen. QDMM:

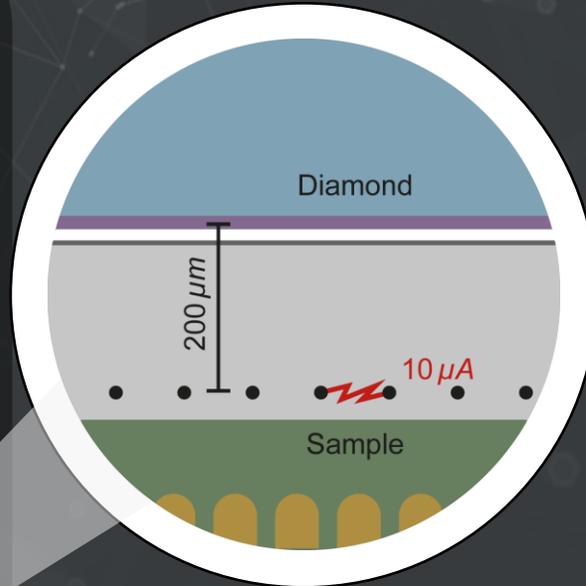
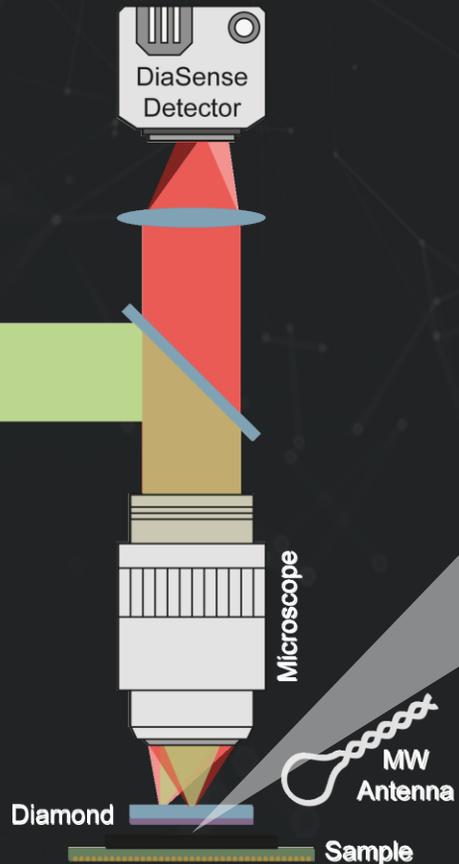
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# Pushing NV sensing beyond CMOS readout

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CMOS-QDMM:

**Measurement time (SNR=1)**  
**> 11 days**

- Magnetic Sensitivity:  $10 \mu T / \sqrt{Hz}$

DiaSense next-gen. QDMM:

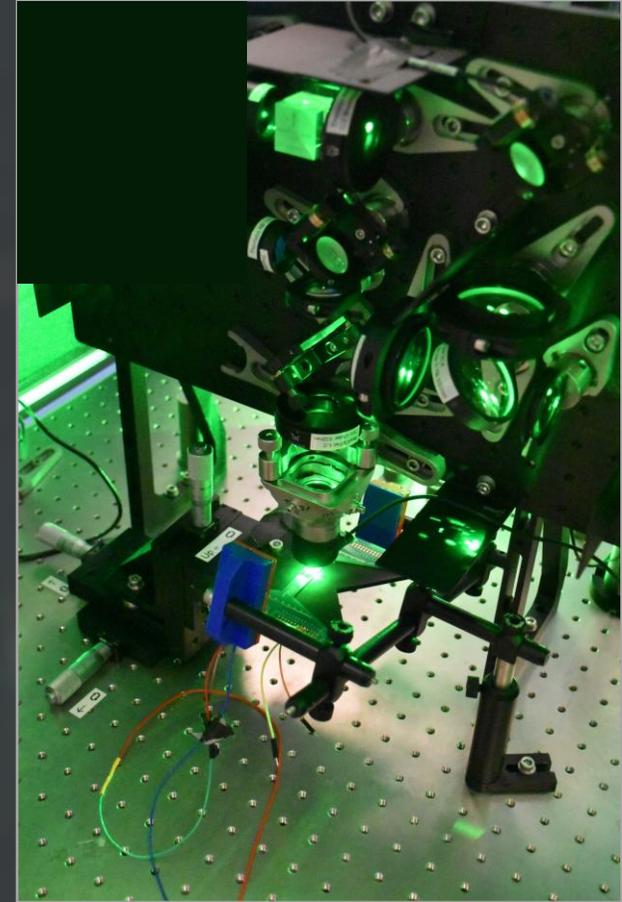
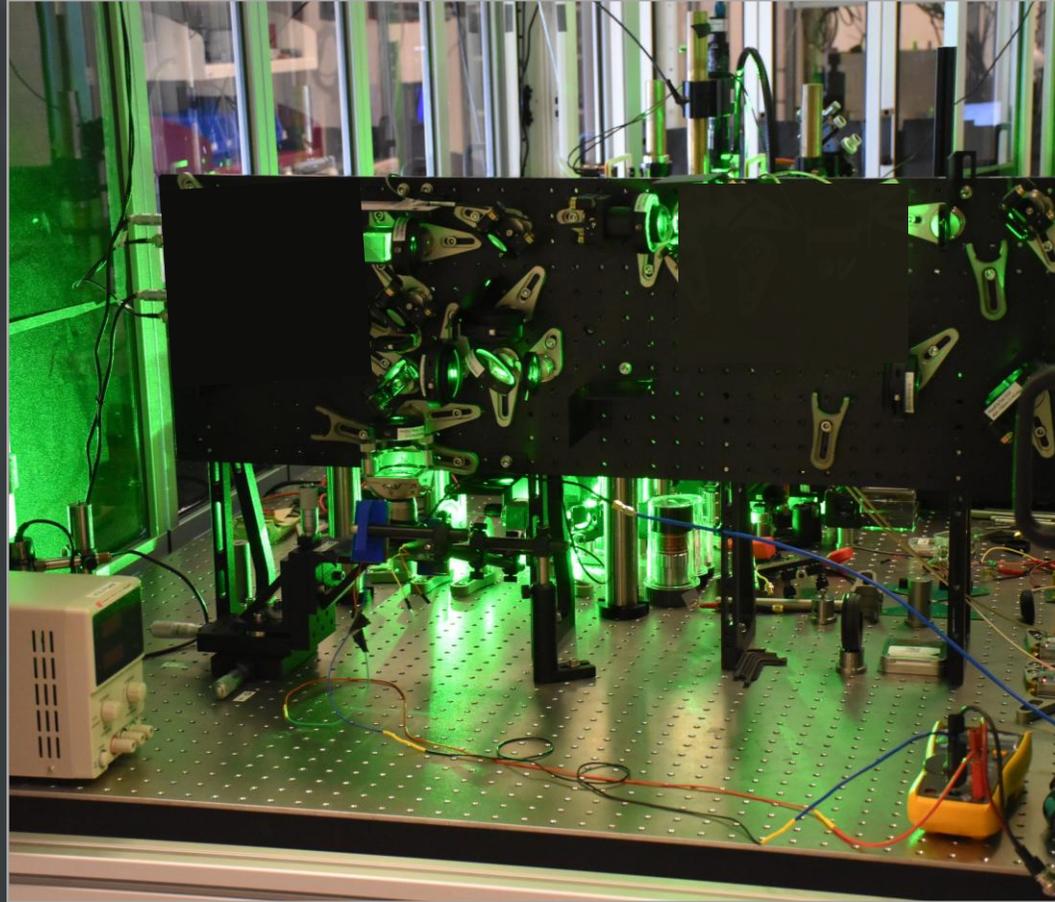
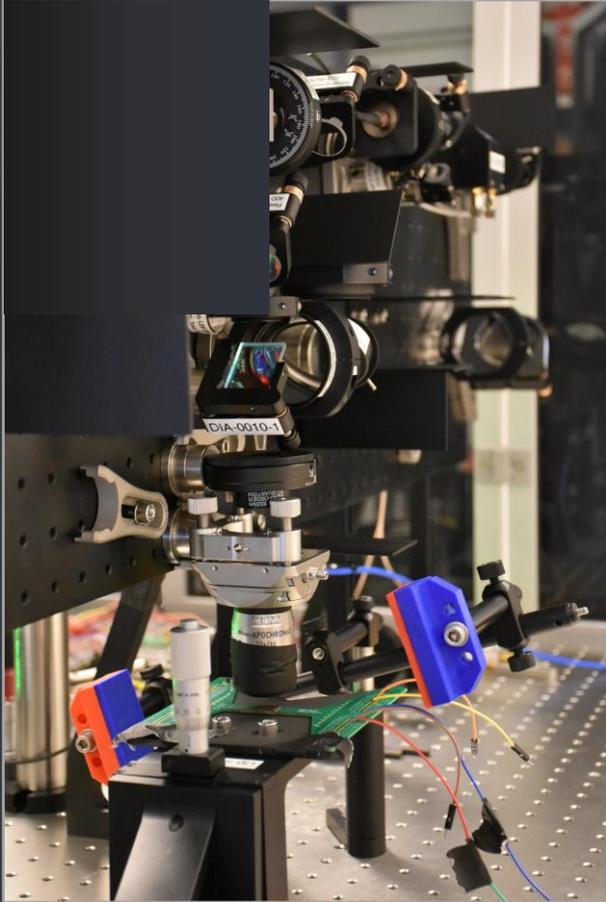
**Measurement time (SNR=1):**  
**1 ~~day~~ second!**

- Magnetic Sensitivity:  $10 - 100 nT / \sqrt{Hz}$

*Our technology breaks the sensitivity barriers that have limited QDMMs for applications in FA and semiconductor metrology so far.*



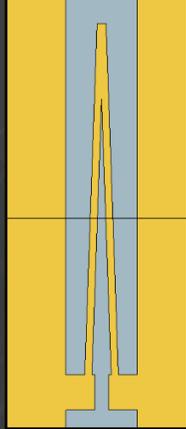
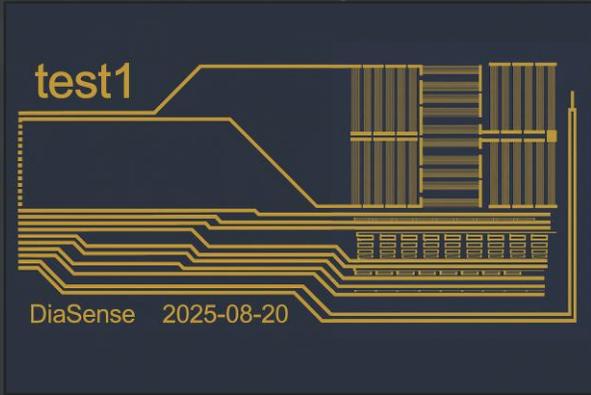
# Prototype images



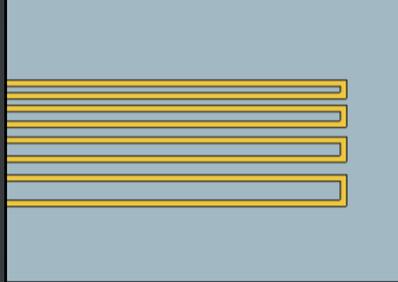


# Seeing Currents Flow

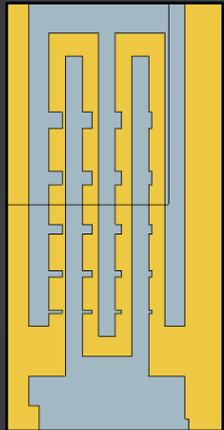
Prototype results validate our core architecture.



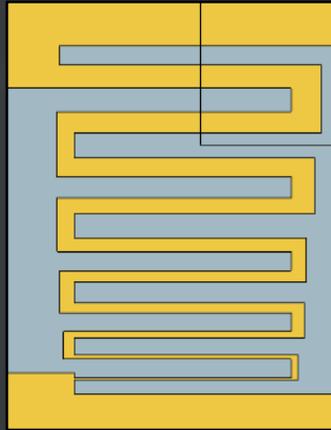
Spike



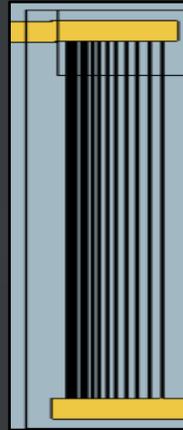
Meander



Wire defects



Width ramp



Spacing ramp

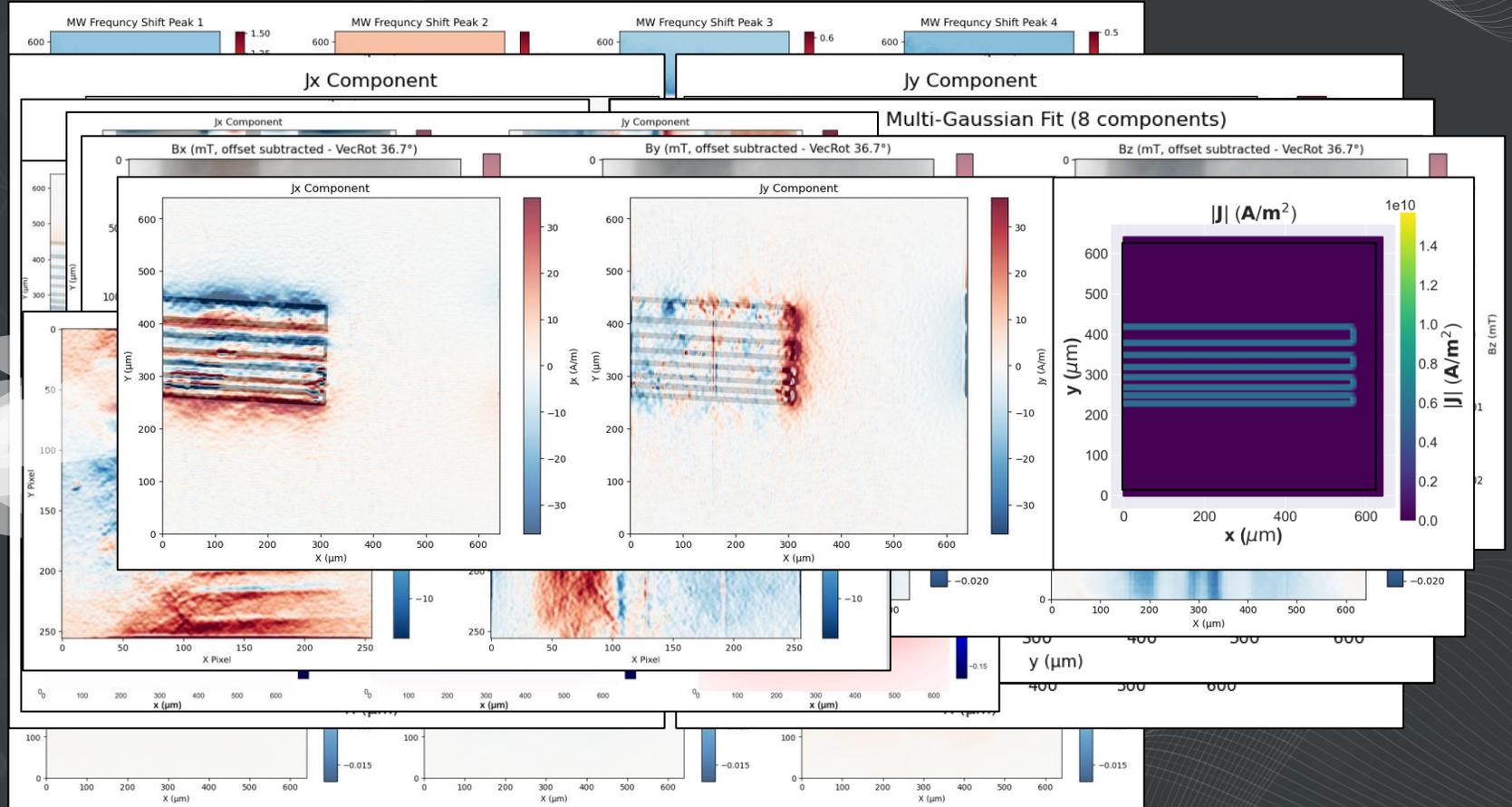
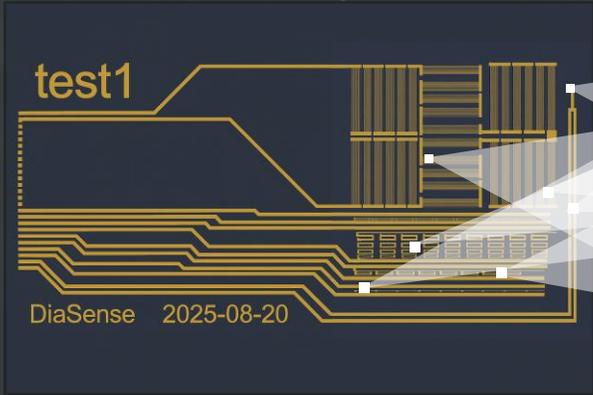
## DiaSense Calibration Chip

- Silicon oxide wafer
- Gold wires  $600\ \mu\text{m}$  thick
- Smallest features:  $10\ \mu\text{m}$
- Max current:  $100\ \text{mA}$



# Seeing Currents Flow

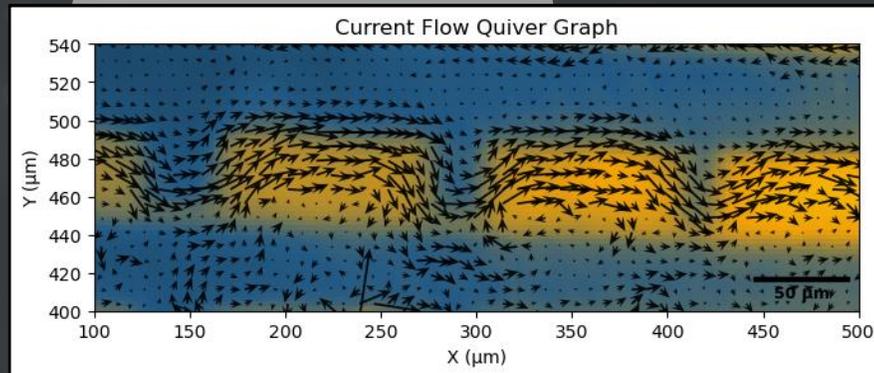
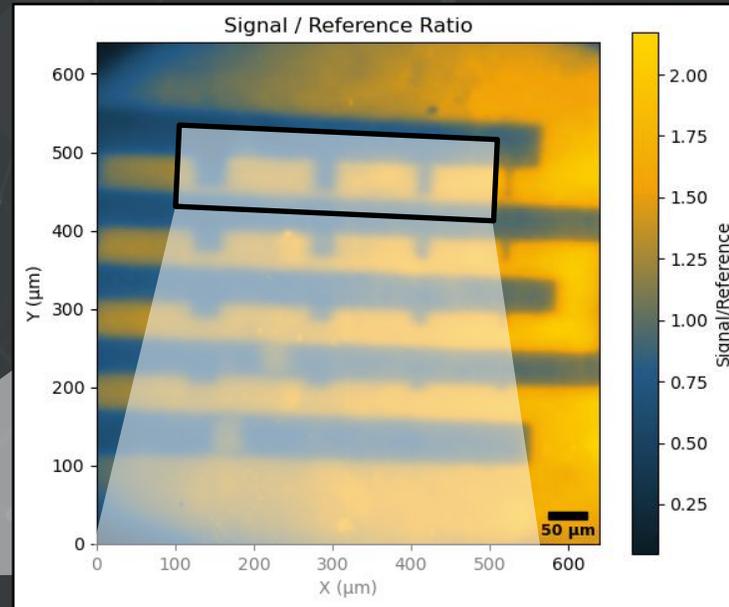
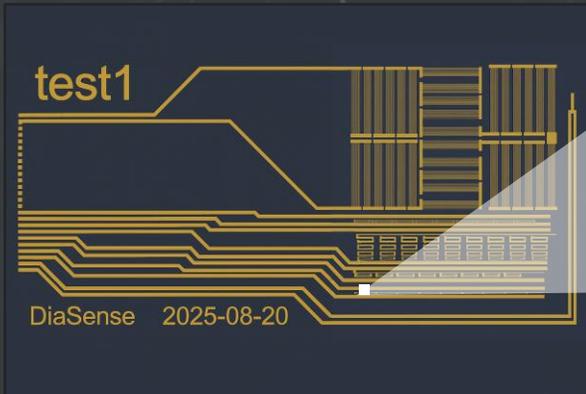
Prototype results validate our core architecture.





# Seeing Currents Flow

Prototype results validate our core architecture.



## Proof of Concept

- Single pixel sensitivity:  $10 \text{ nT} / \sqrt{\text{Hz}}$
- Full image sensitivity:  $< 1 \text{ } \mu\text{T} / \sqrt{\text{Hz}}$
- Current resolution:  $5 \text{ } \mu\text{m}$
- Image size: up to  $2048\text{px} \times 2048\text{px}^*$
- Field of View:  $640\text{ } \mu\text{m} \times 640\text{ } \mu\text{m}$

\* Stitched image from several single measurements.



# Seeing Currents Flow

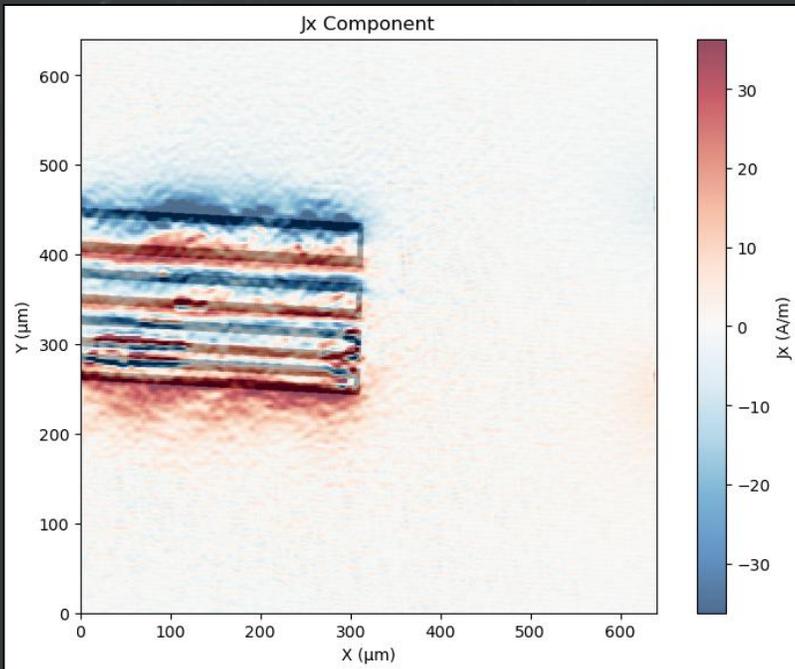
Prototype results validate our core architecture.

**TNG** TECHNOLOGY  
CONSULTING

## Diasense / TNG Collaboration

- Build world-class AI-Team at DiaSense
- Provide expertise in AI-architectures (PINNs, CNNs)\*
- Generate simulated training data
- Provide training infrastructure (HPC)

*Partnering with TNG, a top-tier European AI leader, DiaSense accelerates its leap into AI-enhanced quantum sensing.*



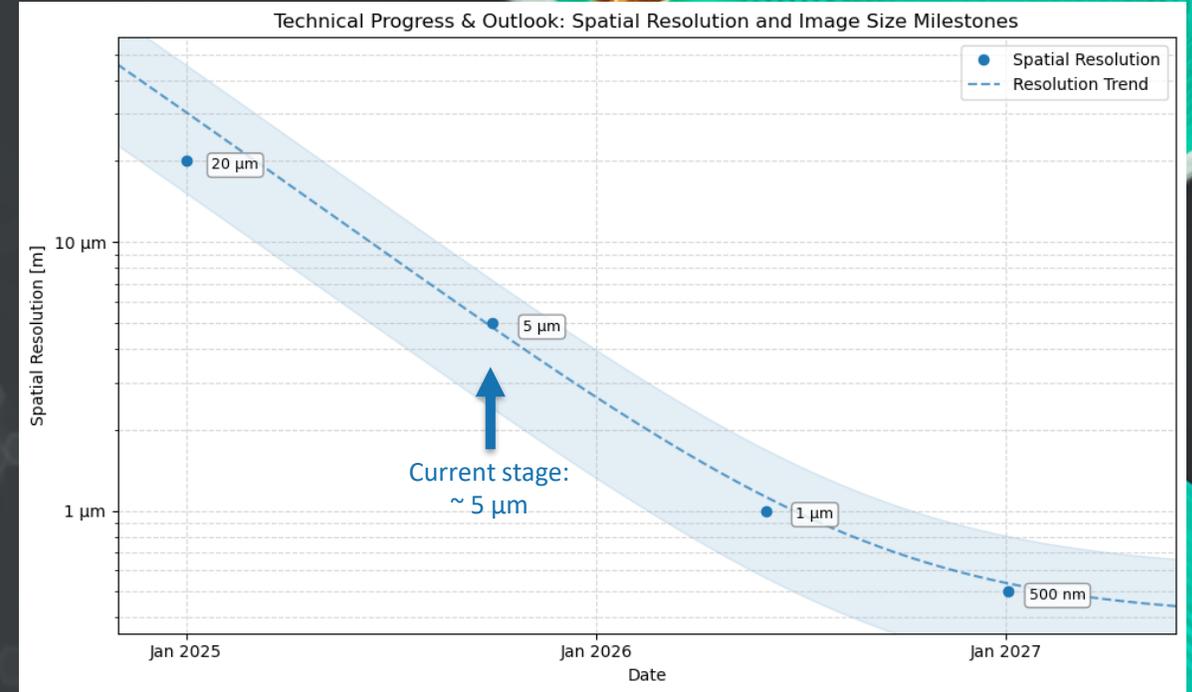
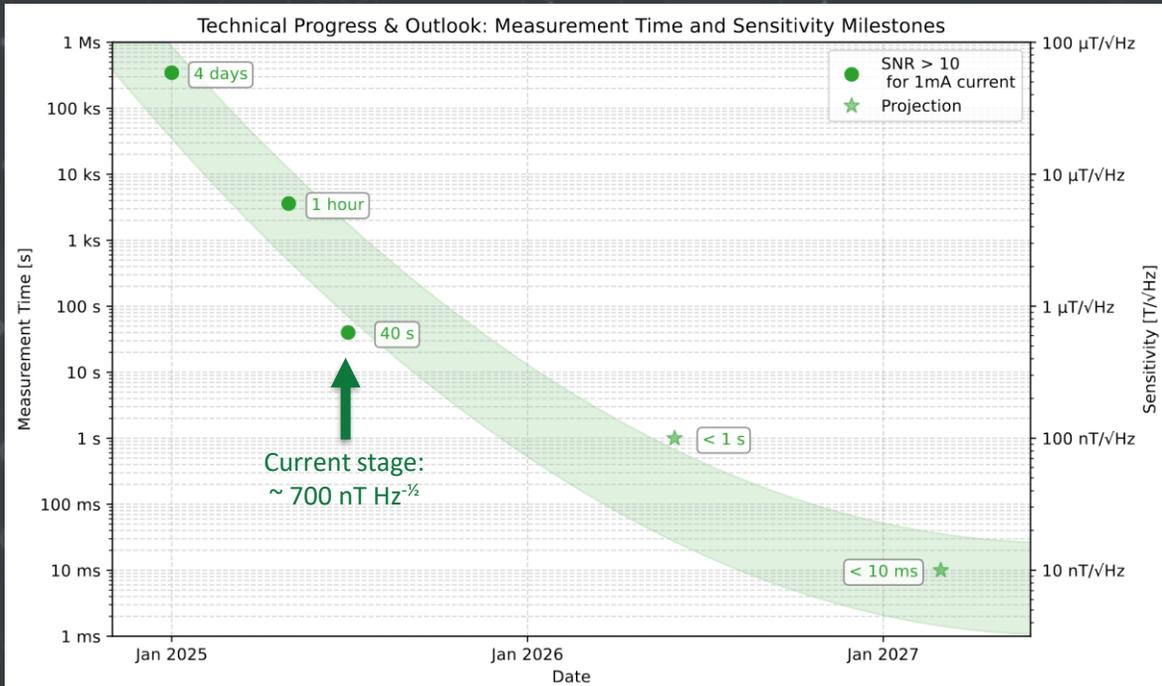
*PINN: Physics Informed Neural Network*

*CNN: Convolutional Neural Network*



# Towards the Quantum Limit

## Next milestones in sensitivity and resolution



*Early prototype results confirm a clear trajectory toward full-spec performance by early 2027.*



# Promising market opportunities

## Failure Analysis

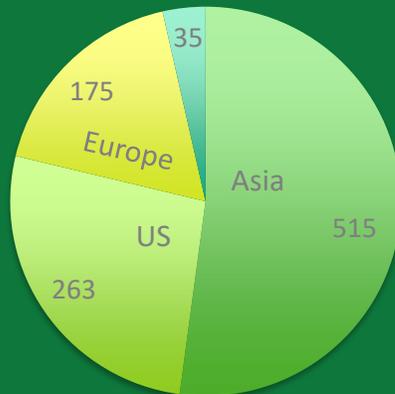
### Customer Segmentation



### Market sizing



Approx. 1000 labs worldwide



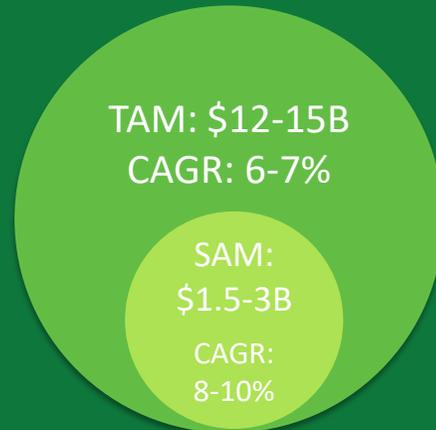
\* (GVR) Failure Analysis Market Size, Share & Trends Report, 2030 (2024)

## Production Test & Monitoring

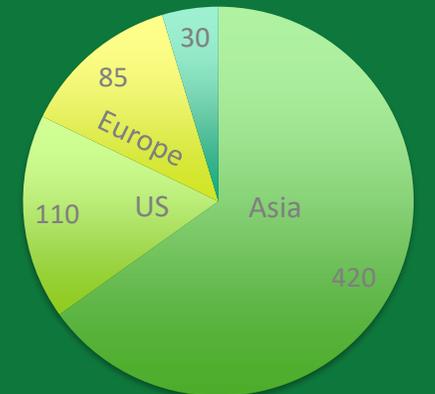
### Customer Segmentation



### Market sizing



Approx. 645 relevant production lines \*



\* Approx. 400-500 new relevant production lines to be established 2029-33



# Promising initial industry traction

Development agreement  
Failure Analysis

Advanced talks  
Production test & metrology

Up next

*With DIASENSE QDMM, Eurofins Maser is shaping the future of semiconductor failure analysis.*



**Purchase Agreement w. down payment**



# Execution – building a winning team to build a winning product

## Major work packages

- User driven design, testing, and benchmarking
- Diamond conditioning with advanced quantum protocols
- Diamond read-out HW and schemes
- AI-driven 3D current reconstruction and failure search
- Optical integration
- Instrument design – incl.  $\mu\text{m}$  precision positioning and probing
- Feature design and implementation
- Software design – platform design
- Market preparation

## Building the Winning Team

Over the next 12-15 months – Q4'25 to Q4'26 – we plan to hire ~10 full time employees and five student assistants – all experts in their field

- Quantum engineers
- Electronics designer
- AI / DSP / Imaging experts
- SW designers
- Instrument designers
- Business and finance executives

Recruiting:

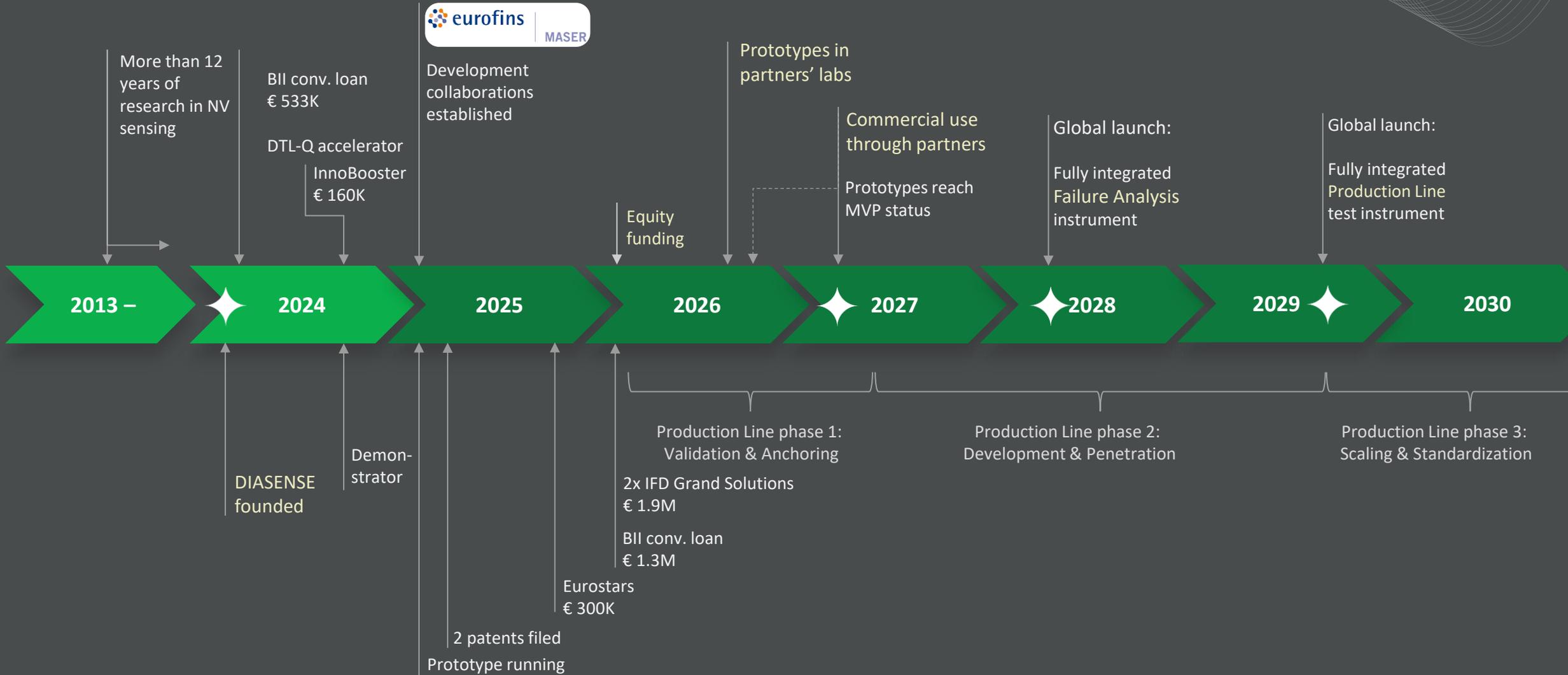
**BLACK  
SWANS  
EXIST**



Further a strong chairman of the board and our advisory board will be established



# Major milestones





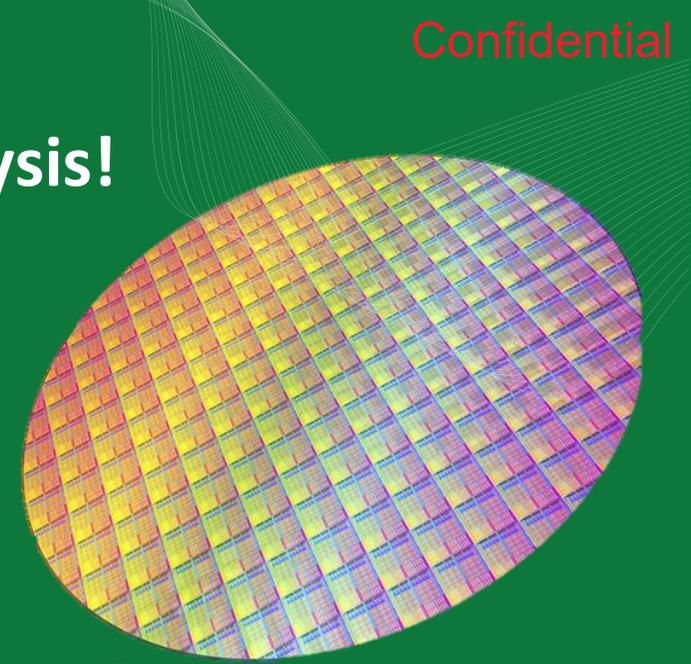
# Join Us to Redefine Chip Test and Failure Analysis!

## We are scaling up ...

- to build a world-class team,
  - to place prototypes at leading partner labs and progress to MVP,
  - to establish proof-of-business – getting ready for Series A
- ... and match granted soft funding (€2.2M) and CL (€1.4M) for 2026-27

## We are also seeking

- **Strong capital partners** who can support us towards series A
- **advisory board members** with deep tech and semiconductor expertise
- **a chairman of the board** to support our next phase of growth





# Backup and quick reference slides



# DIASENSE Quantum Diamond Magnetic Microscope

DIASENSE restores visibility where test and analysis come short

## Value Propositions

### Failure Analysis

- High throughput diagnostics
  - live navigation and smart
- High sensitivity: Uncover subtle defects
  - detect  $\mu\text{A}$  currents in deep
- Non-invasive
  - works on bare dies, packaged

The go-to tool for chip



### Production Test & Monitoring

- Contactless testing
  - leaves wafers, dies, and structures
- Inspect buried structures non-destructively
  - monitor TSVs, RDLs, and 3D
- Fast fingerprinting: detect production defects
  - identify non-uniformities and

The essential tool for in-





# Seeing where others can't

DiaSense QDMM uniquely resolves buried faults in depth.

Method	Diasense QDMM	Conv. QDMM	Scanning QDMM	MMI*	OBRICH*	LIT*
Principle	Next-gen detector & laser drive	CMOS widefield	AFM tip scanning	(GMR/SQUID sensors)	IR laser + resistance change	Thermal emission
Strengths	high sensitivity 3D capable	3D capable	high resolution	3D capable	High sensitivity, fast	Fast hotspot detection
Weaknesses		Limited sensitivity	Limited sensitivity	Low resolution cryogenic	Indirect measurement only 2D	Limited resolution only 2D

\* MMI: (Magnetic Microscopy Imaging)

OBRICH: (Optical Beam Induced Resistance Change)

LIT: (Lock-in Thermography)

